



H&A-104

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

K. NAGATA et al

Serial No. 09/924,575

Group Art Unit: 2881

Filed: August 9, 2001

Examiner: L. Nguyen

For: METHOD AND APPARATUS FOR CHARGED  
PARTICLE BEAM EXPOSURE

AMENDMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed November 6, 2003,  
please amend the above-identified application as follows.

RECEIVED  
JAN 28 2004  
TECHNOLOGY CENTER 2800